<table>
<thead>
<tr>
<th><strong>Title</strong></th>
<th>Tuning InAs quantum dots for high areal density and wideband emission</th>
</tr>
</thead>
<tbody>
<tr>
<td><strong>Author(s)</strong></td>
<td>Ngo, C. Y.; Yoon, Soon Fatt; Fan, Weijun; Chua, S. J.</td>
</tr>
<tr>
<td><strong>Date</strong></td>
<td>2007</td>
</tr>
<tr>
<td><strong>URL</strong></td>
<td><a href="http://hdl.handle.net/10220/18130">http://hdl.handle.net/10220/18130</a></td>
</tr>
<tr>
<td><strong>Rights</strong></td>
<td>© 2007 American Institute of Physics. This paper was published in Applied Physics Letters and is made available as an electronic reprint (preprint) with permission of American Institute of Physics. The paper can be found at the following official DOI: <a href="http://dx.doi.org/10.1063/1.2713148">http://dx.doi.org/10.1063/1.2713148</a>. One print or electronic copy may be made for personal use only. Systematic or multiple reproduction, distribution to multiple locations via electronic or other means, duplication of any material in this paper for a fee or for commercial purposes, or modification of the content of the paper is prohibited and is subject to penalties under law.</td>
</tr>
</tbody>
</table>
Tuning InAs quantum dots for high areal density and wideband emission

C. Y. Ngo, S. F. Yoon, and W. J. Fan
School of Electrical and Electronic Engineering, Nanyang Technological University, Nanyang Avenue, Singapore 639798, Republic of Singapore

S. J. Chua
Faculty of Engineering, Institute of Materials Research and Engineering, 3 Research Link, Singapore 117602, Republic of Singapore

(Received 5 December 2006; accepted 6 February 2007; published online 12 March 2007)

The authors report the effect of growth temperature and monolayer coverage on areal density and photoluminescence spectral width of InAs quantum dot (QD). Areal density and spectral width were found to be strongly dependent on growth temperature and monolayer coverage, respectively. Upon proper tuning, both high areal density and large photoluminescence spectral width were obtained. Areal density of $1.5 \times 10^{11} \text{ cm}^{-2}$ is four times higher than those previously reported, while spectral width of 136 nm is the broadest spectral width obtained without any forms of band gap engineering. These results will contribute to an improvement in the performance of QD superluminescent diode. © 2007 American Institute of Physics. [DOI: 10.1063/1.2713148]

Superluminescent diodes (SLDs) are important broadband light sources for applications in optical measurement systems such as optical gyroscopes and sensors, short and medium distance optical communication systems, and biomolecular imaging based on optical coherent tomography. For such applications, quantum dot (QD) system is proposed to be the best candidate for ultrawide spectrum due to inhomogeneous broadening of its gain spectrum as a result of the size nonuniformity in self-assembled quantum dots. In particular, high output power and large optical bandwidth are key figures of merit for QD-SLDs. Common methods to increase the operating power include tilted-stripe structure, antireflection coating, or multiple QD layers, while spectral width is increased by growing chirped QD structure or utilizing emission from the excited states. As such, QD-SLD with high continuous wave output power of 200 mW was demonstrated at room temperature using a tilted-stripe structure with multiple QD layers, while large spectral width of 121 nm was demonstrated with the use of chirped QD structure and utilizing ES emission. However, due to the small photoluminescence (PL) spectral width contributed by each QD layer, chirped QD structure must be properly designed. Otherwise, the PL spectral will exhibit intensity peaks and valleys.

For high power broadband applications, both high dot areal density and large size inhomogeneity are desired. High dot areal density ($1 \times 10^{11} \text{ cm}^{-2}$) will improve the optical output power of QD-SLDs since, unlike QD lasers, emission from QD-SLDs is contributed by QDs of all sizes. Size inhomogeneity in small QDs, as compared to large QDs, is preferred as this will result in larger energy range, implying a wider spectral width. In fact, size inhomogeneity of $10\%$ occurs naturally in self-assembly QD growth, and it was reported that typical In(Ga)As QDs with size inhomogeneity of $10\%$ give a PL spectral width of $60-80 \text{ meV}$. The fact that this energy range is similar to the PL results seems to imply that no effort was made to increase the QD size inhomogeneity within each QD layer. Furthermore, as reported, the areal density of the InAs QDs only ranges from $1.0 \times 10^{10}$ to $3.5 \times 10^{10} \text{ cm}^{-2}$. Hence, there is no report on optimization of the InAs QD active layers for SLD applications, i.e., to increase both the QD areal density and PL spectral width.

In the present work, we investigated the effects of growth temperature ($T_g$) and monolayer coverage ($\theta_m$) on the areal density and PL spectral width of the InAs QD samples. As such, the $T_g$ investigated were 450, 480, and 510 °C, while the $\theta_m$ investigated were 2.0, 2.5, and 3.0 ML. Our samples were grown using solid-source molecular beam epitaxy. A 250-nm-thick GaAs buffer layer was grown on semi-insulating GaAs (001) substrate before growing $\theta_m$ of InAs QDs at substrate temperature of $T_g$. The QDs were then capped with 5 nm of In$_{0.15}$Ga$_{0.85}$As strain reducing layer to tune the ground state emission to around 1.3 μm. This was followed by a 40-nm-thick GaAs spacer layer to decouple the electronic and strain effects of the QD layers, before repeating the above growth sequence for another layer of capped InAs QDs with the same monolayer coverage as the first layer. Finally, a layer of uncapped InAs QDs of the same monolayer coverage was grown for atomic force microscopy (AFM) characterization. The PL properties of the InAs QD samples were measured at room temperature (RT) using the 5145 Å line of an Ar$^+$ laser. The PL signals were detected using a liquid nitrogen cooled Ge detector in conjunction with a standard lock-in technique.

Figure 1 shows the InAs QD areal density ($10^{10} \text{ cm}^{-2}$) and RT-PL spectral width as a function of growth conditions. The trend of variation is divided into regions I and II, namely, $\theta_m$ variation at 450 °C and $T_g$ variation at 2.0 ML, respectively. One can see that lower $T_g$ leads to higher dot areal density. Hence, regardless of monolayer coverage, the dot areal density obtained at 450 °C is still higher than that grown at higher $T_g$. As reported, the increase in dot areal density at low $T_g$ is due to reduction of the adatom migration length. Hence, impinging adatoms is more likely to form new sites on the surface instead of combining with existing dots. Furthermore, we see an increase in PL spectral width following a decrease in the

Electronic mail: ngoce0003@ntu.edu.sg
monolayer coverage. Again, note that regardless of growth temperature, the spectral width of the PL spectra at 2.0 ML coverage is still larger (>100 nm) than that grown at higher $T_g$. As reported by Joyce et al., the 2.0 ML coverage provides insufficient material for the InAs QDs to reach its mature size. Hence, the large PL spectral width is due to the low InAs monolayer coverage, leading to a large number of QDs in various stages of development and consequently resulting in large QD size variation, as reflected by the wide PL spectral width.

The inset in Fig. 1 presents the integrated PL intensity as a function of growth conditions, while Fig. 2 shows the RT-PL spectra and AFM images (as insets) of the InAs QD samples grown at (a) 3.0 ML, 450 °C and (b) 2.0 ML, 510 °C. Hence, while high dot areal density can be obtained at low $T_g$, regardless of monolayer coverage, integrated PL intensity decreases and the number of large islands with width of ~100 nm increases following the increase in $T_g$ [as shown in inset of Fig. 2(a)]. As reported, transmission electron microscopy studies have shown the presence of dislocations within the large islands. Hence, these islands are nonradiative and act as a sink for photogenerated carriers, thus degrading the PL efficiency. On the other hand, while large spectral width (implying large size nonuniformity) can be obtained from low InAs coverage, the areal density decreases significantly following the increase in $T_g$. This is due to the exponential increase in In desorption rate at high growth temperature, hence giving rise to the sharp decrease in the areal density, as observed in Fig. 1 and the AFM image in inset of Fig. 2(b). The corresponding decrease in the integrated PL intensity is expected since, as mentioned above, low areal density (~0.7 x 10^10 cm^-2) is detrimental to the output power of QD-SLDs. While extraction of the actual dot height from AFM is relatively straightforward, this is not so for the dot width (lateral size) due to convolution effects between the AFM tip and the dot. In this work, all AFM image widths have been corrected to obtain the actual widths (lateral size). The size nonuniformities for the insets of Figs. 2(a) and 2(b) are calculated to be 12.3% and 19.4%, respectively. It should be noted that the large islands in the inset of Fig. 2(a) are excluded from the nonuniformity calculations since they are nonradiative. The increase in size nonuniformity following the decrease in monolayer coverage is expected and can be inferred from the spectral widths of the PL spectra in Fig. 2.

As seen from Fig. 1, InAs QD areal density is strongly dependent on the growth temperature, while the size nonuniformity (thus spectral width of the PL spectrum) is strongly dependent on the monolayer coverage. This implies the ability to tune the dot areal density and size nonuniformity separately by changing the InAs QD growth conditions. Hence, using suitable monolayers coverage and growth temperature, one can obtain high dot areal density and large spectral width. As depicted in Fig. 1, this is realized for InAs QD sample grown at 2.0 ML and 450 °C, and Fig. 3 shows the (a) AFM image and (b) RT-PL spectra of the sample under various fractions of excitation power. The QD areal density obtained from the AFM image was 1.5 x 10^11 cm^-2 and the size nonuniformity was calculated to be 19.0%. This areal density is approximately four times higher than those previously reported and is expected to contribute to the higher output power of QD-SLDs. Comparison of the PL spectrum at 1.0P_0 with that at 0.25P_0 suggests that the broadband emission is contributed by a convolution of various ground and excited state emissions. This explains the presence of the shorter wavelength peaks at higher excitation conditions.
density and size nonuniformity of InAs QDs. Under conditions of InAs QD growth temperatures at 450, 480, and 510 °C and monolayer coverages at 2.0, 2.5, and 3.0 ML, the InAs QD areal density was found to be strongly dependent on the growth temperature while the size nonuniformity was found to be strongly dependent on the monolayer coverage. With proper tuning of growth temperature and monolayer coverage, we had achieved both high areal density ($1.5 \times 10^{11} \text{cm}^{-2}$) and large RT-PL spectral width (136 nm). These results will contribute to an improvement in the performance of the current QD-SLDs.

The authors greatly acknowledge the discussions with Sun Zhongzhe. This project is partially supported by funding under the A’STAR Graduate Scholarship program.

20. Using $w_d = \sqrt{w_t^2 - 8r}\ h$, where $w_d$, $w_t$, $r$, and $h$ are the actual dot width, AFM image width, radius of curvature of the tip, and dot height, respectively. Derivation of the formula is included in the Appendix of J. Appl. Phys. (unpublished).
21. Nonuniformity is defined as the ratio of the standard deviation of the sample size to the average of the sample size.